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TO: TECHNOLOGY CENTER 2823 DATE: AUGUST 21, 2003

AFTER FINAL

COMPANY: U.S. PATENT AND TRADEMARK OFFICE

FROM: EUGENE M. LEE, REG. NO. 32,039

FAX NUMBER: 703.872-9319 TOTAL NO. OF PAGES INCLUDING COVER: 8

PHONE NUMBER: YOUR REFERENCE NUMBER:

CC: OUR REFERENCE NUMBER:

RE: U.S. PATENT APPLICATION SERIAL NO. 09/686,624

Transmitted herewith is:

AMENDMENT AFTER FINAL PURSUANT TO 37 C.F.R. \$1.116

in connection with application Serial No. 09/686,624 pending in Art Unit 2823 before Examiner Khiem D. Nguyen.

Return receipt, via facsimile [to 703.525.4265], of the above-referenced document(s) is hereby requested.

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AUG 2 1 2003

GROUP 2800

AFTER FINAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Jung-Ho Lee, et al.

Serial No.: 09/686,624

Filed: October 12, 2000

For: Spin-on Glass Composition and Method of Forming Silicon
Oxide Layer in Semiconductor
Manufacturing Process
Using the Same

Commissioner for Patents United States Patent and Trademark Office P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL PURSUANT TO 37 C.F.R. § 1.116

Sir:

INTRODUCTORY COMMENT

In response to the Office Action mailed May 21, 2003, and made final, kindly amend the above-identified application as follows: